



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of)
Shunpei YAMAZAKI, ET AL.)
Serial No. 07/852,517) Art Unit: 2508
Filed: March 17, 1992) Examiner: M. Saadat
For: SEMICONDUCTOR MATER-)
IAL AND METHOD FOR)
FORMING THE SAME AND)
THIN FILM TRANSISTOR)

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner of Patents and Trademarks, Washington, D.C. 20231, on 6/15/93.

R. Friedman

AMENDMENT

Honorable Commissioner of Patents and Trademarks
Washington, D.C. 20231

JUL 09 1993

0756-711-2500

Sir:

In response to the Official Action of March 15, 1993, please amend the above-identified application as follows:

IN THE CLAIMS:

Please amend claims 4, 18 and 20 as follows:

Claim 4, line 2, delete "or YAG laser".

18. (Amended) A thin film transistor comprising an [intrinsic or] at least substantially intrinsic semiconductor included in a channel of said thin